IN THE CLAIMS

Please amend the claims as previously amended under Article 34 as follows:

- 1. (Original) A thermal processing unit comprising:
- a heating-furnace body whose upper end has an opening,
- a reaction tube consisting of a single tube contained in the heating-furnace body,
- a gas-discharging-unit connecting portion formed at an upper portion of the reaction tube, the gas-discharging-unit connecting portion having a narrow diameter,
- a substrate-to-be-processed supporting member for supporting a substrate to be processed, contained in the heating-furnace body, and
- a heating unit for heating the substrate to be processed supported by the substrate-to-be-processed supporting member,

wherein the heating unit has:

- a first heating portion arranged around the reaction tube,
- a second heating portion arranged around the gas-discharging-unit connecting portion,
 - a third heating portion arranged around an upper portion of the reaction tube,
- a fourth heating portion arranged around a lower portion of the reaction tube, and
- a fifth heating portion arranged under the substrate-to-be-processed supporting member.
- 2. (Original) A thermal processing unit according to claim 1, wherein the first heating portion is formed by a plurality of linear heat-generating members, which are arranged in parallel with a longitudinal direction of the reaction tube.
- 3. (Original) A thermal processing unit according to claim 1, wherein

the first heating portion is formed by a plurality of U-shaped heat-generating members, which are arranged in parallel with a longitudinal direction of the reaction tube.

4. (Currently Amended) A thermal processing unit according to any of claims 1 to 3 claim 1, wherein

the second heating portion is formed by a linear heat-generating member, which is arranged in a spiral pattern.

5. (Currently Amended) A thermal processing unit according to any of claims 1 to 4 claim 1, wherein

the third heating portion is formed by a linear heat-generating member, which is arranged in a spiral pattern.

6. (Currently Amended) A thermal processing unit according to any of claims 1 to 4 claim 1, wherein

the third heating portion is formed by a linear heat-generating member, which is arranged in a switchback pattern.

7. (Currently Amended) A thermal processing unit according to any of claims 1-to-6 claim 1, wherein

the fourth heating portion is formed by a linear heat-generating member, which is arranged in a spiral pattern that is seen as a rectangular in a circumferential direction of the reaction tube.

8. (Currently Amended) A thermal processing unit according to any of claims 1 to 6 claim 1, wherein

the fourth heating portion is formed by a linear heat-generating member, which is arranged in a switchback pattern.

9. (Currently Amended) A thermal processing unit according to any of claims 1 to 8 claim 1, wherein

the fifth heating portion is formed by a plate-like heat-generating member.

10. (Currently Amended) A thermal processing unit according to any of claims 1-to 8 claim 1, wherein

the fifth heating portion is formed by a heat-generating member arranged along a lower surface of the substrate-to-be-processed supporting member.

11. (Currently Amended) A thermal processing unit according to any of claims 2 to 4 and 8 claim 2, wherein

the linear heat-generating member is formed by sealing a resistance heater into a hollow tubular member made of ceramics.

12. (Original) A thermal processing unit according to claim 9, wherein the plate-like heat-generating member is formed by sealing a resistance heater into a hollow plate-like member made of ceramics.

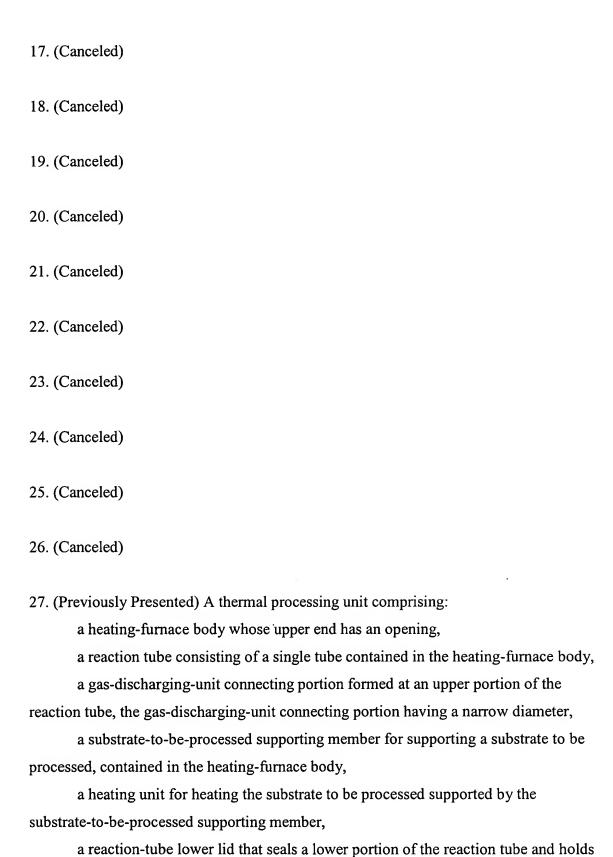
13. (Currently Amended) A thermal processing unit according to elaim 11 or 12 claim 11, wherein

the ceramics is quartz.

14. (Currently Amended) A thermal processing unit according to any of claims 1 to 13 claim 1, wherein

the second heating portion is supported in a movable manner in a horizontal direction.

- 15. (Canceled)
- 16. (Canceled)



airtightness in the reaction tube, and

a temperature measuring unit formed by sealing a plurality of temperature measuring members into a hollow tubular member,

wherein the hollow tubular member is arranged in a gap between the heatingfurnace body and the reaction tube.

28. (Cancelled)

29. (Original) A thermal processing unit comprising:

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a heating-furnace body whose upper end has an opening,

a reaction tube consisting of a single tube contained in the heating-furnace body,

a gas-discharging-unit connecting portion formed at an upper portion of the reaction tube, the gas-discharging-unit connecting portion having a narrow diameter,

a substrate-to-be-processed supporting member for supporting a substrate to be processed, contained in the heating-furnace body,

a heating unit for heating the substrate to be processed supported by the substrate-to-be-processed supporting member,

a reaction-tube lower lid that seals a lower portion of the reaction tube and holds airtightness in the reaction tube,

a second temperature measuring unit formed by sealing a plurality of temperature measuring members into a second hollow tubular member, and

a third temperature measuring unit formed by sealing a plurality of temperature measuring members into a third hollow tubular member,

wherein at least a portion of the second hollow tubular member extends horizontally from an upper portion of the reaction tube, and

at least a portion of the third hollow tubular member is arranged in a gap between the heating-furnace body and the reaction tube.

30. (Canceled)

31. (Original) A thermal processing unit comprising:

a heating-furnace body whose upper end has an opening,

a reaction tube consisting of a single tube contained in the heating-furnace body, a gas-discharging-unit connecting portion formed at an upper portion of the

reaction tube, the gas-discharging-unit connecting portion having a narrow diameter,

a substrate-to-be-processed supporting member for supporting a substrate to be processed, contained in the heating-furnace body,

a heating unit for heating the substrate to be processed supported by the substrate-to-be-processed supporting member,

a reaction-tube lower lid that seals a lower portion of the reaction tube and holds airtightness in the reaction tube,

a second temperature measuring unit formed by sealing a plurality of temperature measuring members into a second hollow tubular member, and

a third temperature measuring unit formed by sealing a plurality of temperature measuring members into a third hollow tubular member,

wherein the heating unit has:

- a first heating portion arranged around the reaction tube,
- a second heating portion arranged around the gas-discharging-unit connecting portion,
- a third heating portion arranged around an upper portion of the reaction tube,
- a fourth heating portion arranged around a lower portion of the reaction tube, and
- a fifth heating portion arranged under the substrate-to-be-processed supporting member,

at least a portion of the second hollow tubular member extends horizontally from an upper portion of the reaction tube, and

at least a portion of the third hollow tubular member is arranged in a gap between the heating-furnace body and the reaction tube.

32. (Cancelled)

33. (Currently Amended) A thermal processing unit according to claim 31 or 32, wherein

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a temperature controlling unit is provided around the gas-discharging-unit connecting portion.

- 34. (Original) A thermal processing unit according to claim 33, wherein the temperature controlling unit is a heat-insulating material.
- 35. (Original) A thermal processing unit according to claim 33, wherein the temperature controlling unit is a resistance heater.
- 36. (Currently Amended) A thermal processing unit according to claim 34 or 35, wherein

the temperature controlling unit has flexibility.

37. (Currently Amended) A thermal processing unit according to claim 34 or 35, wherein

the temperature controlling unit is shaped in advance.

38. (Currently Amended) A thermal processing unit according to any of claims 31 to 37 claim 31, wherein

the gas-discharging unit is a gas-discharging pipe whose end portion has a flange,

a flange is formed at an end portion of the gas-discharging-unit connecting portion, and

the flange at the end portion of the gas-discharging-unit connecting portion and the flange at the end portion of the gas-discharging pipe are hermetically connected to each other by means of a sealing unit.

39. (Original) A thermal processing unit according to claim 38, wherein the temperature controlling unit has a fluid hole provided in the flange.